

## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of: Attorney Docket: SLA0809  
Inventor: Apostolos T. Voutsas, et al. Confirmation No. 1722  
Serial No.: 10/713,383 Group #: 1722  
Filed: November 13, 2003 Examiner: R. M. Kumermund  
Title: METHOD AND PROCESS FOR LONG CRYSTAL LATERAL GROWTH IN  
SILICON FILMS BY UV AND IR PULSE SEQUENCING

Commissioner for Patents  
P.O. Box 1450  
Alexandria, Virginia 22313-1450

## ASSOCIATE POWER OF ATTORNEY

## CHANGE OF CORRESPONDENCE ADDRESS

I hereby appoint Gerald Maliszewski, of P. O. Box 270829, San Diego, CA 92198-2829, U. S. Patent and Trademark Office Registration Number 38,054, as an associate attorney for the above-captioned matter, with full power of substitution and revocation, to prosecute this application and to transact all business in the Patent and Trademark Office connected therewith.

Please change the Correspondence address to that associated with Customer Number 55286.

Date: 10/18/05

Respectfully submitted,

  
David C. Ripma, Registration # 27,672

David C. Ripma Patent Counsel  
Sharp Laboratories of America, Inc.  
5750 N.W. Pacific Rim Highway  
Camas, WA 98607  
Phone: (360) 834-8754  
Facsimile: (360) 817-8505

Page 1 Associate Power of Attorney for Serial No. 10/713,383